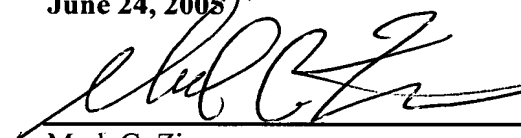




IFW

PATENT
Docket No. 20063/OG03-046

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant(s):) I hereby certify that this paper and the
) documents referred to as enclosed
In Su KIM) therewith are being deposited with the
) United States Postal Service as first
U.S. Serial No.: 10/758,188) class mail, postage prepaid, in an
) envelope addressed to Commissioner
For: "Methods of Fabricating) for Patents, P.O. Box 1450,
Semiconductor Devices") Alexandria, Virginia 22313-1450 on
) this date:
Filed: 1/15/2004)
) **June 24, 2005**
Group Art Unit: 2811)
)
Examiner: Not Yet Assigned)
) 
) Mark C. Zimmerman
) Attorney for Applicant(s)
) Registration No. 44,006

STATUS LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

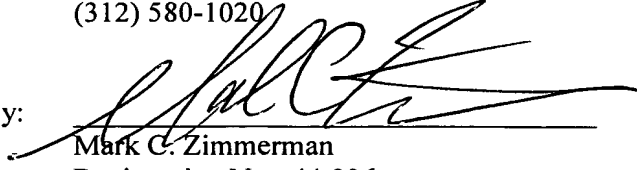
Kindly advise when an Office action can be expected in the above-referenced matter.

Respectfully submitted,

HANLEY, FLIGHT & ZIMMERMAN, LLC
USPTO Customer Number 34431
20 North Wacker Drive
Suite 4220
Chicago, Illinois 60606
(312) 580-1020

June 24, 2005

By:


Mark C. Zimmerman
Registration No.: 44,006